



ON THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/810,387
Confirmation No. 8779
Filing Date March 15, 2001
Inventor..... Craig M. Carpenter
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1763
Examiner R. Zervigon
Attorney's Docket No. MI22-1559
Customer No. 021567
Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

RESPONSE TO DECEMBER 21, 2004 OFFICE ACTION

To: MS AMENDMENT
Commissioner for Patents
PO Box 1450
Art Unit 1763
Alexandria, VA 22313

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AMENDMENTS

04/25/2005 JBALINAN 00000079 09810387

02 FC:1201 200.00 0P
03 FC:1202 50.00 0P

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